

MSE-735

Nom Prénom	Lab	exam paper	place	14.1.	15.1.	21.1.
Song Shuqing	LAS		Sion	14:30		
Wang Shaoyu	LAS	engineering grain boundaries	Sion	14:00		
Gautam Siddharth	NANOLAB	TKD HfO thin films	MXC-118		10:30	
Rajadhyax Richa Ashish	INE	ADF-STEM Tomo	MXC-118		11:00	
Xie Qishan	LBEN	dose efficient Cryo	MXC-118		11:30	
Liu Chang	INE	cryo-STEM mapping	MXC-118		14:00	
Tenna Edoardo	NANOLAB	atomic scale characterization...	MXC-118		14:30	
Shcherbacheva Elizaveta	INE	operando TEM	MXC-118			11:00
Zamani Aliabadi Mohammadreza	LMTM (NE)		MXC-118			10:30